## Search Notes



Application/Control No.	Applicant(s)/Patent Under Reexamination
10550450	ICHIMURA ET AL.
Examiner	Art Unit
Zhu, John	2858 .

SEARCHED						
Class	Subclass	Date	Examiner			
324	663	7/9/2006	MK			
324	522	7/9/2006	MK			
324	713	7/9/2006	MK			

SEARCH NOTES				
Search Notes	Date	Examiner		
search 73/514.01-520.01 wiht keyword for MEMS type sensors	7/9/2006	MK		
Review International search report	7/9/2006	MK		
Update EAST keyword search, see notes	1/10/2007	JZ		

INTERFERENCE SEARCH							
Class	Subclass	Date	Examiner				

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